

Kurt J. Lesker
Company

PVD 75

Thin Film Deposition System



PVD 75

A versatile, value engineered,
thin film deposition system
for *YOUR* research
or production
application.

Process Modules:

- Organic Evaporation
- Magnetron Sputtering
- Thermal Evaporation
- E-beam Evaporation
- Ion Sources

Together With:

- Ease of Use
- Process Flexibility
- Low Cost of Ownership

From the leader in
PVD systems, sources
and solutions.

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